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Keywords: radiation hardness, nanostructures, nanostructured materials, ion irradiation, structural and parametric degradation.

Basayev A. S., Danilyuk A. L., Andreyenko A. V., Labunov V. A., Prudnikava A. L., Tagachenkov A. M., Yanushkevich K. I. *Magnetic Structure Simulation of Cementite Nanoparticles En-capsulated in Carbon Nanotubes. Part 2* 12
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Keywords: carbon nanotube, cementite, nanomaterials, magnetism, vortex magnetic structure, single-domain length.

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Keywords: lasing heterostructure, semiconductor laser, epitaxy, semiinsulator-burried procedure, power-current and direct modulation characteristics.

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